

METHOD FOR FORMING A CHAMBER IN AN ELECTRONIC
DEVICE AND DEVICE FORMED THEREBY

ABSTRACT

5 A method is disclosed for forming a chamber in an electronic device,
including the steps of preparing an outer surface on a solidified core material,
the solidified core material in a depression formed in a substrate. The method
further includes establishing a layer on the prepared outer surface of the
solidified core material and a portion of the substrate surrounding the
10 depression. The established layer and the substrate define a chamber.